



1110-94326 PATENT

DO NOT ENTER: /MS/

05/21/2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/534,946
 Applicant : YOKOYAMA et al.
 Filed : 11 May 2005
 Art Unit : 1792
 Examiner : SONG, Mathew J.
 Docket No. : 1110-94326
 Customer No. : 24628
 Title : SILICON WAFER, ITS
 MANUFACTURING METHOD, AND ITS
 MANUFACTURING APPARATUS

Confirmation No.: 3657

**CERTIFICATE OF MAILING BY
FIRST CLASS MAIL (37 CFR 1.8)**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313, on the date below.

Robert T. Shuler
9 April 2008
(Date)

ENTERED BY
RCJ
6/19/08
JAS

AMENDMENT

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of January 10, 2008 has been carefully reviewed and the following amendments and remarks are made in response thereto: